

# Longitudinal Density Monitor

## LDM Techniques using synchrotron radiation

Non-linear mixing of SR with short-pulse laser light

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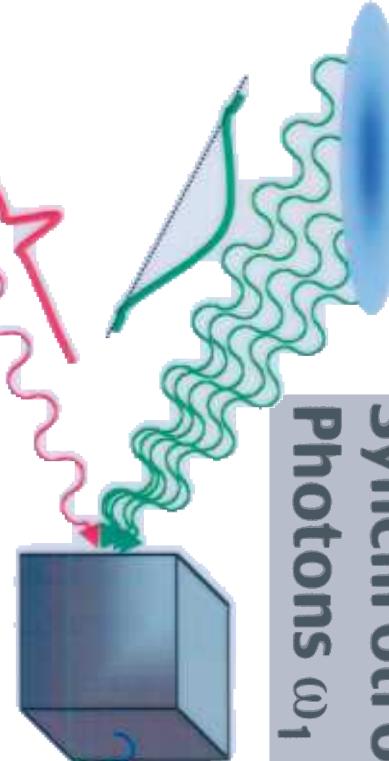
M. Zolotorev

# Concept

Bunch

Synchrotron  
Photons  $\omega_1$

Mixed  
Photons  $\omega_1 + \omega_2$



Non-linear

crystal

Laser  
Photons  $\omega_2$  [BBO]

Filter( $\omega_1 + \omega_2$ )

PMT

## Frequency up conversion

$$P_{i3} = \chi^{(1)}_{ik} E_{k3} + \chi^{(2)}_{ilm} E_{l1} E_{m2}$$

$$\omega_3 = \omega_1 + \omega_2$$

$$\chi^{(2)} \approx 1/E_{\text{atomic}}$$

$$E_{\text{atomic}} \approx 10 \text{ V}/\text{\AA} = 10^{11} \text{ V}/\text{m}$$

For example for BBO crystal ( $B_aB_2O_4$ )

$$\chi^{(2)} \approx 2 \text{ pm}/\text{V}$$

Conversion efficiency for moderate laser intensities  
is strongly dependent on phase matching

### lase matching condition

$$\begin{aligned} &= \omega_1 + \omega_2 \\ &= K_1 + K_2 \\ \omega_3 &= n(\omega_1) \omega_1 + n(\omega_2) \omega_2 \end{aligned}$$

rotron light conversion efficiency

$$\eta \approx \frac{\sin^2 \left[ \frac{1 \Delta k}{2} \right]}{\left( \frac{\Delta k L_e}{2} \right)^2}$$

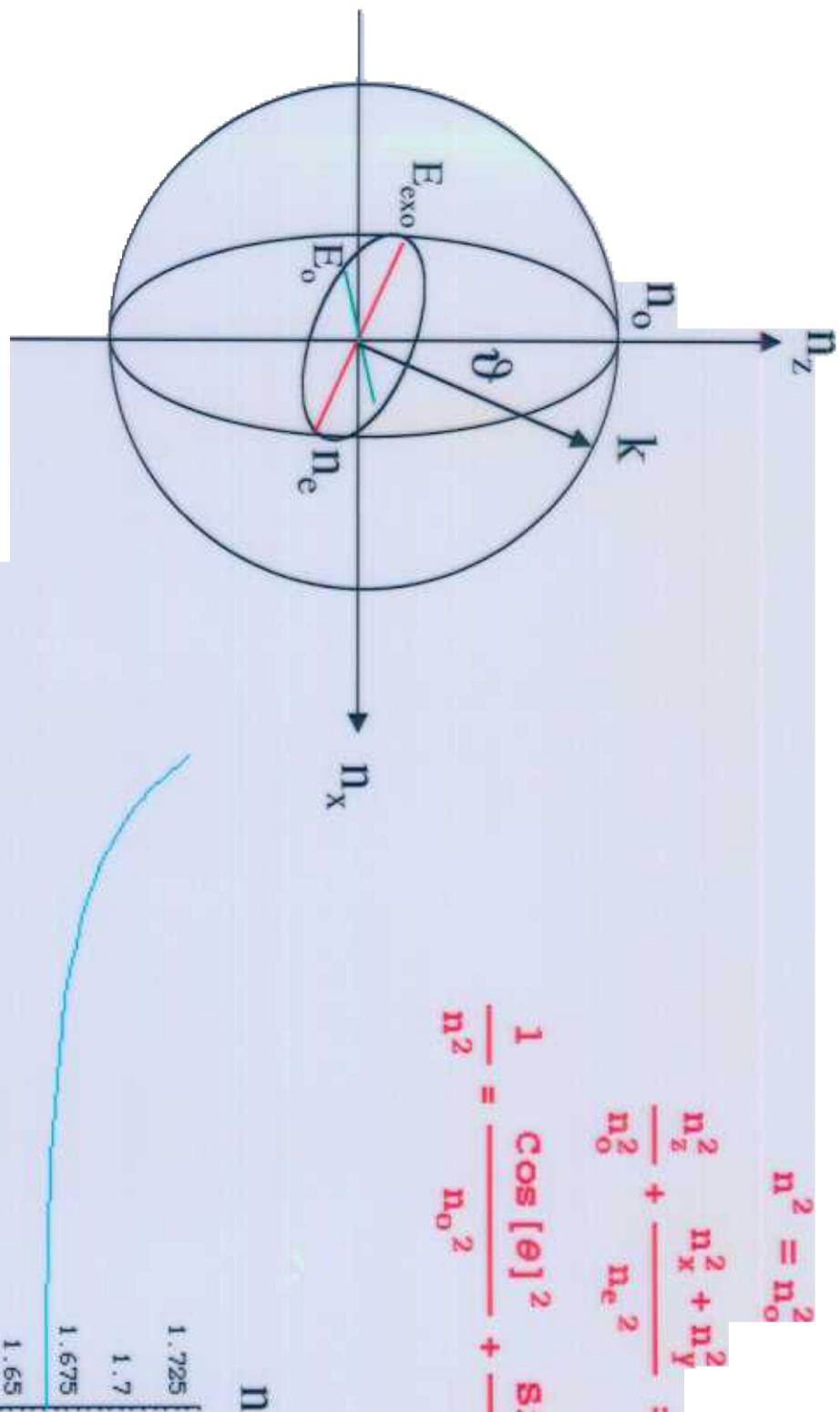
For a given crystal type and wavelength and under optimal focusing this depends only on laser pulse power,  
is independent of crystal thickness

O crystal, Laser 1nJ 50fs 800nm, synchrotron light 630nm  
es conversion efficiency  $10^{-3}$

$$n^2 = n_o^2$$

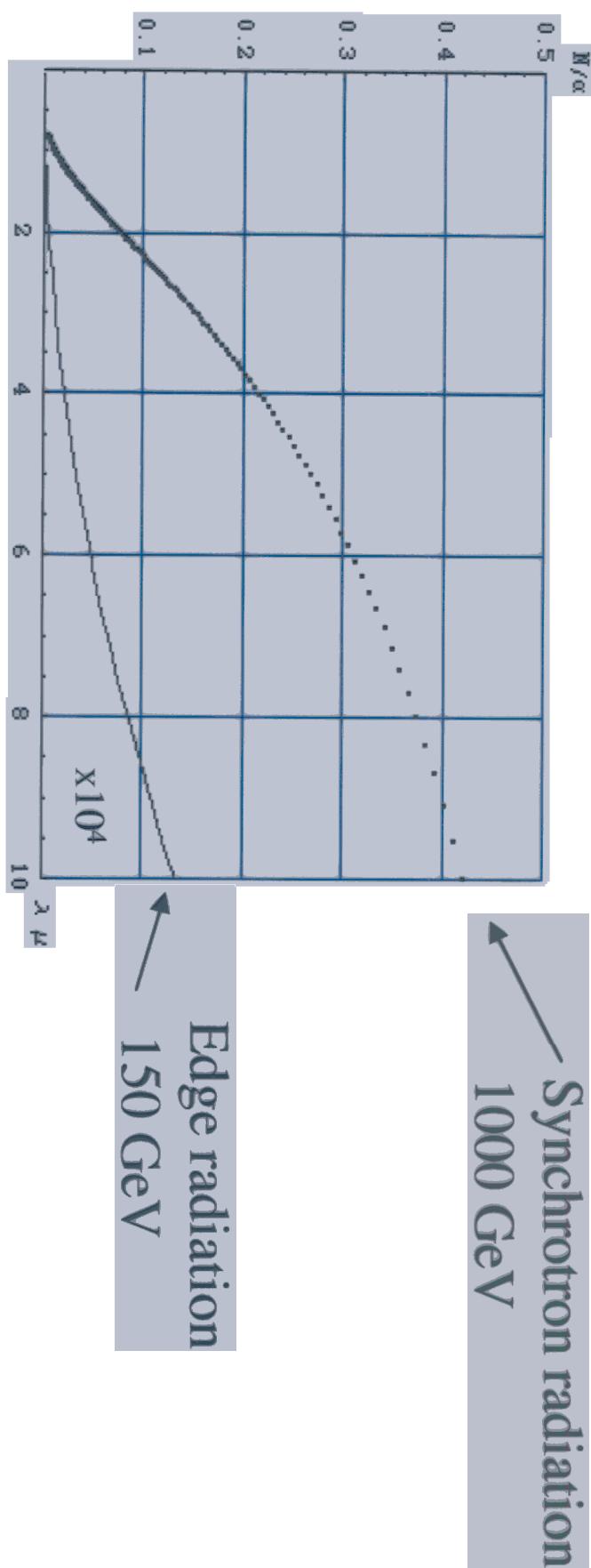
$$\frac{n_z^2}{n_o^2} + \frac{n_x^2 + n_y^2}{n_e^2} = 1$$

$$\frac{1}{n^2} = \frac{\cos[\theta]^2}{n_o^2} + \frac{\sin[\theta]^2}{n_e^2}$$

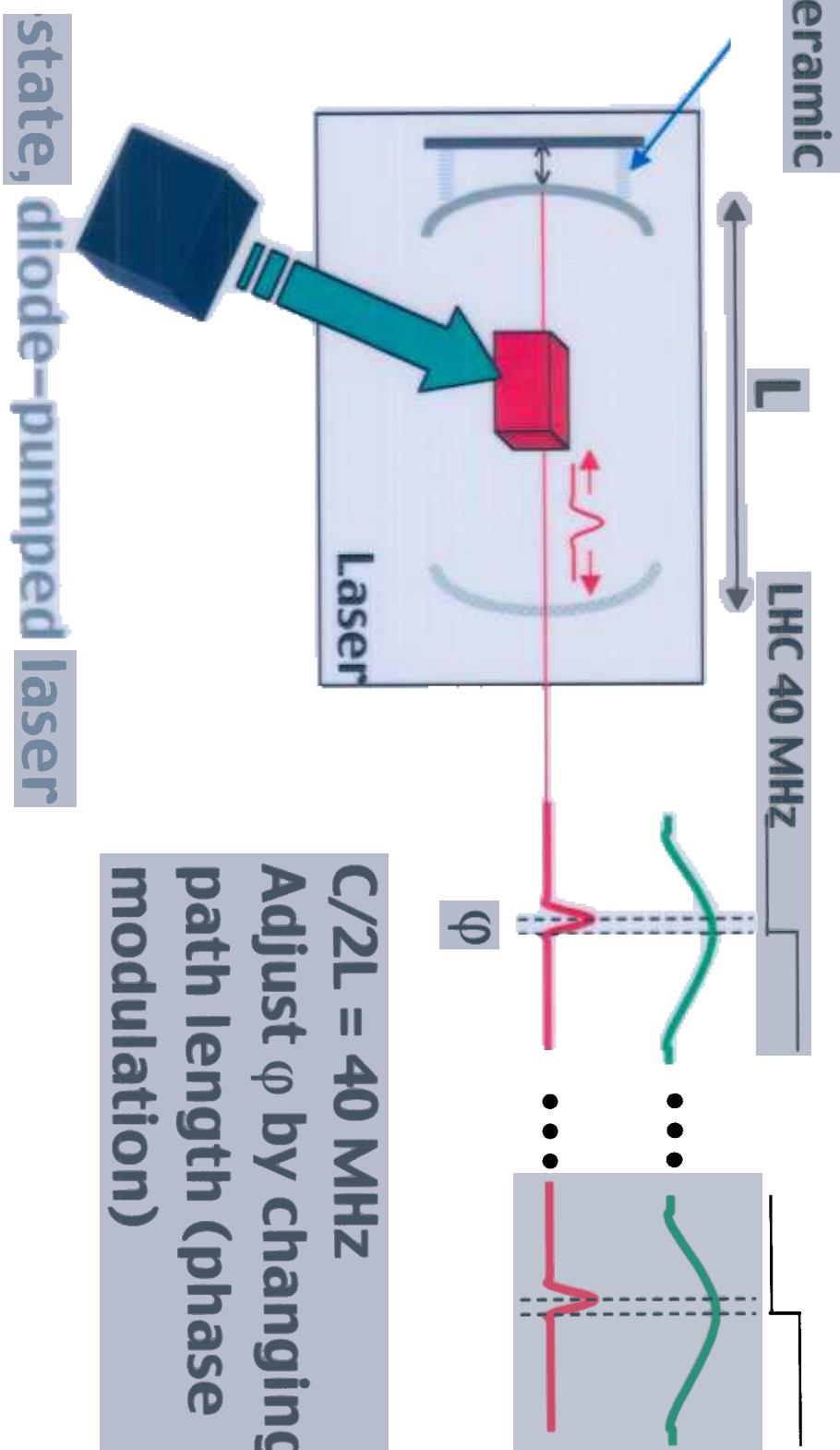


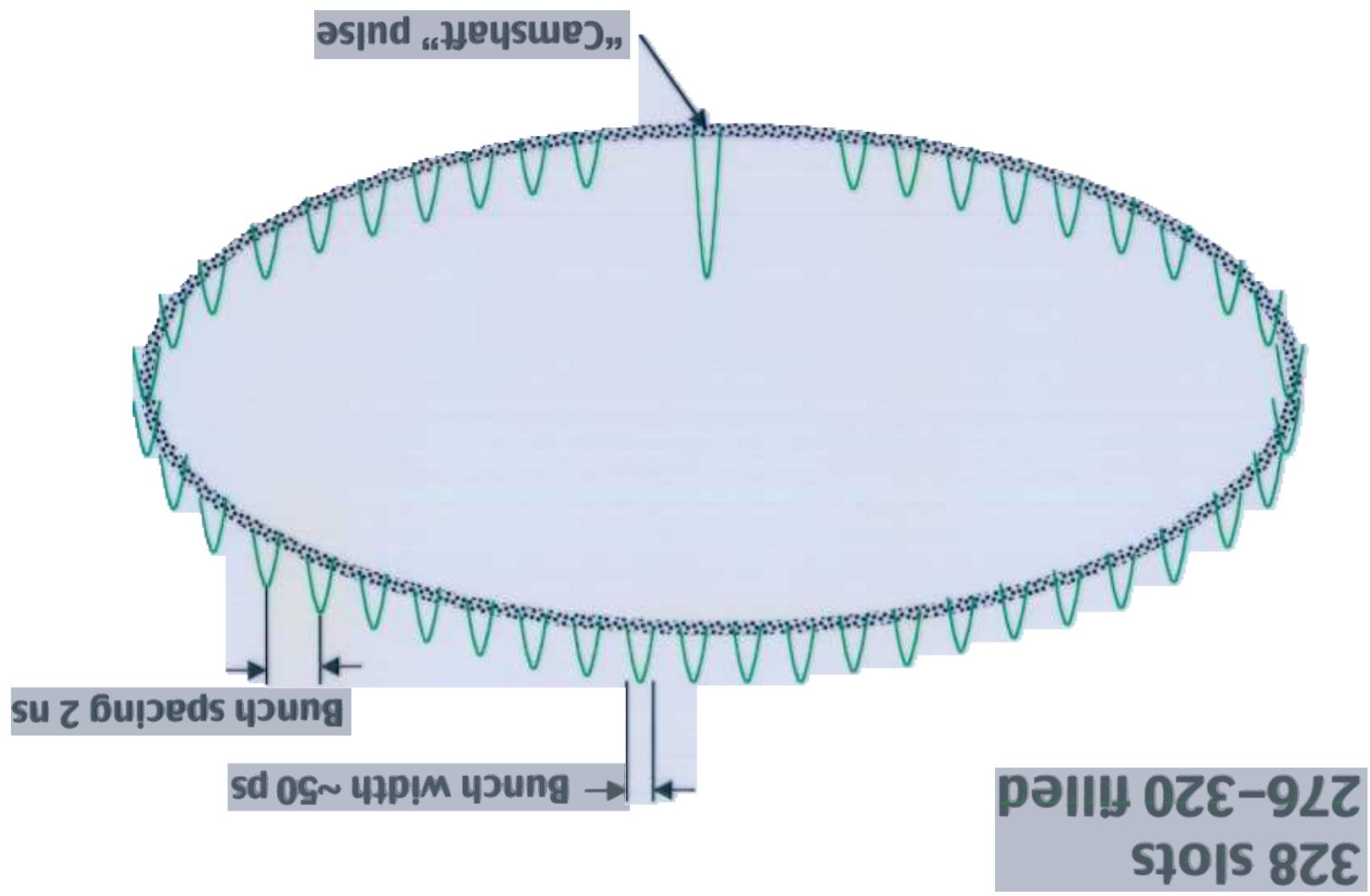
# Synchrotron radiation for Tevatron (1000 GeV )

## Edge radiation for Tevatron (150 Gev )



# Scanning the Bunch





Test at the ALs

## Setup

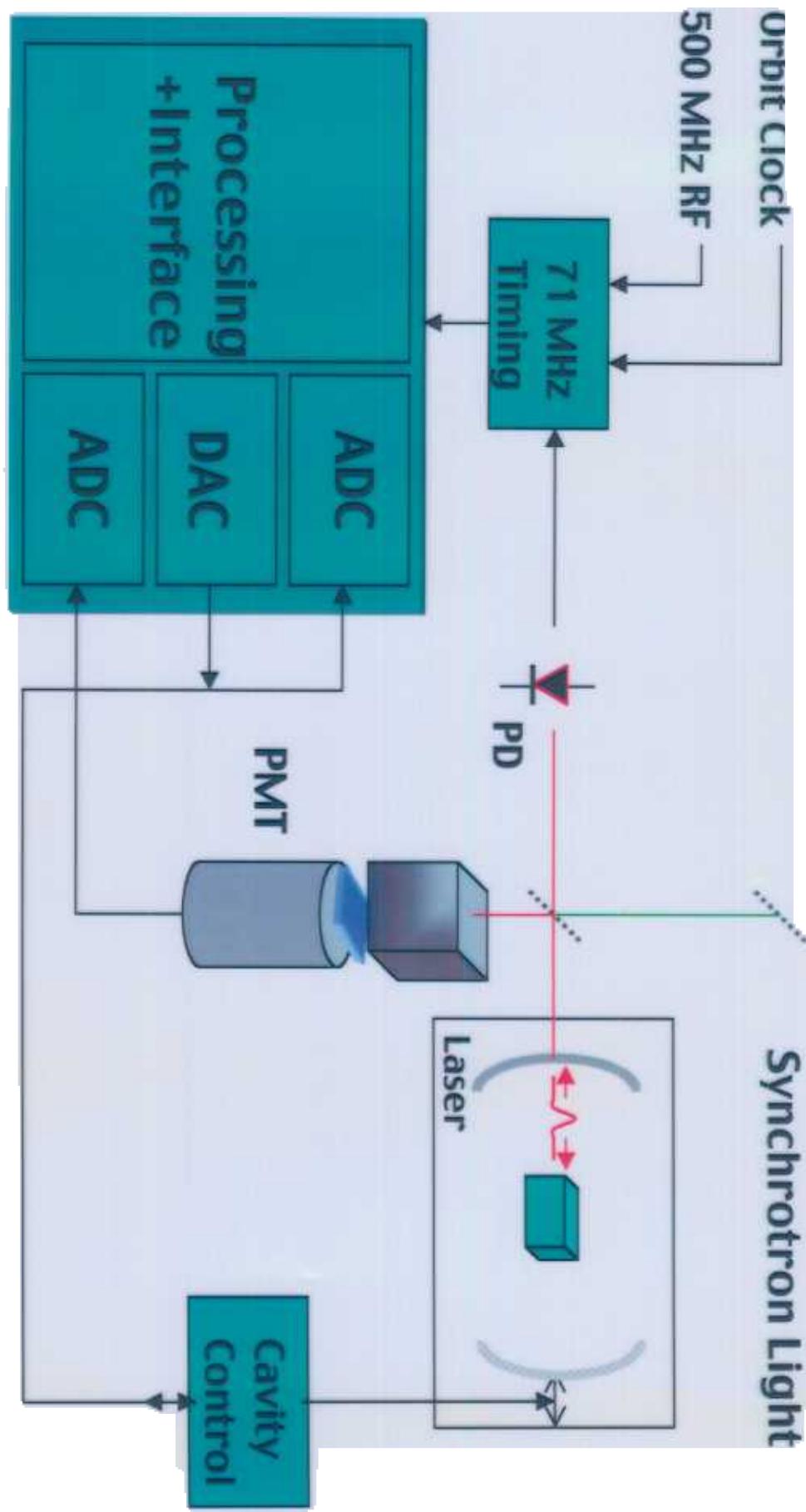
- In Beamline 5.3.1 using existing fs laser
- Laser repetition frequency is 71 MHz (1/7 ALS frequency)
- Scan bunches in groups of 7, then shift 1 bunch  
(0, 7, 14...; 1, 8, 15...; ... ; 6, 13, 20...)

## Electronics, DAQ + Software

- Histograms the signal from each bunch
- Drives mirror with programmable displacement
- Profiles the mirror displacement (for bin position in time)

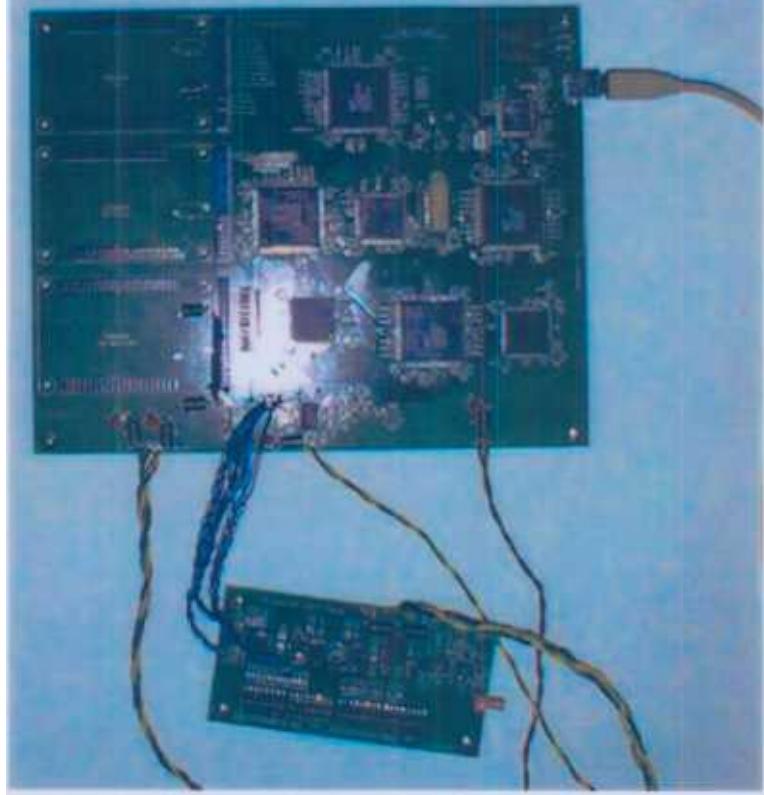
**Some results from the first run – just to give a flavor of what is possible ...**

# Schematic



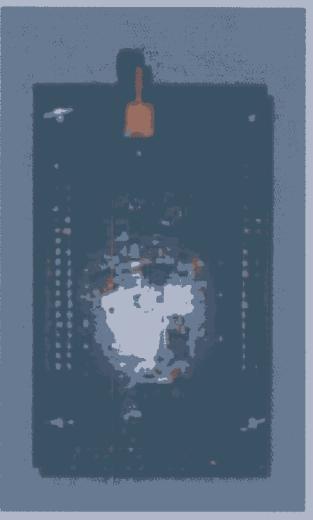
# Electronics - I.

## Mother Board with 71MHz clock board

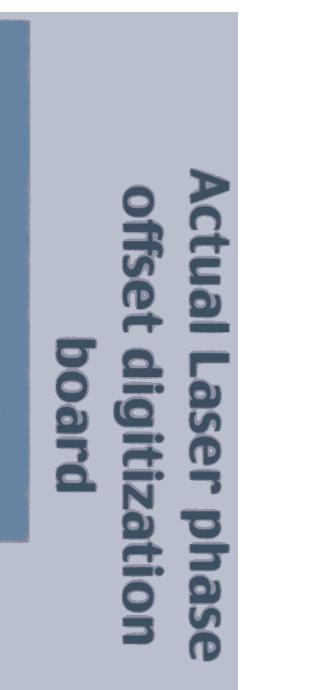


USB Control and histogram/average is fully operational

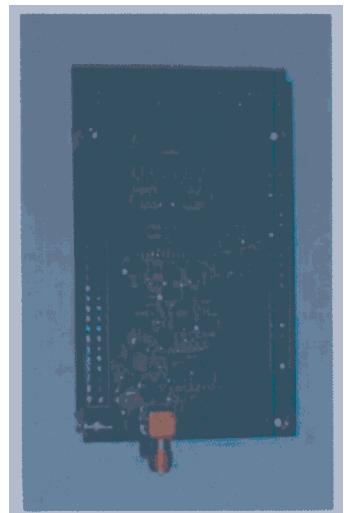
## Electronics - II.



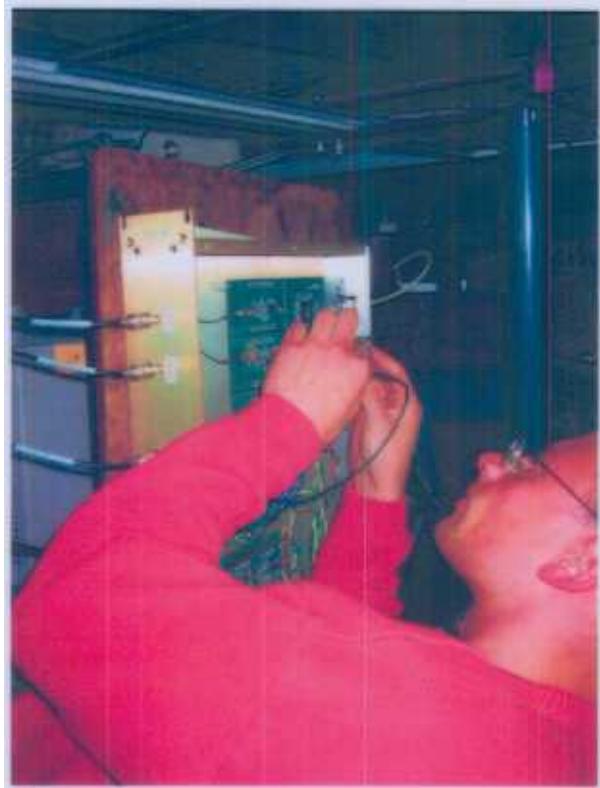
DAC Analog board for  
laser phase offset  
modulation



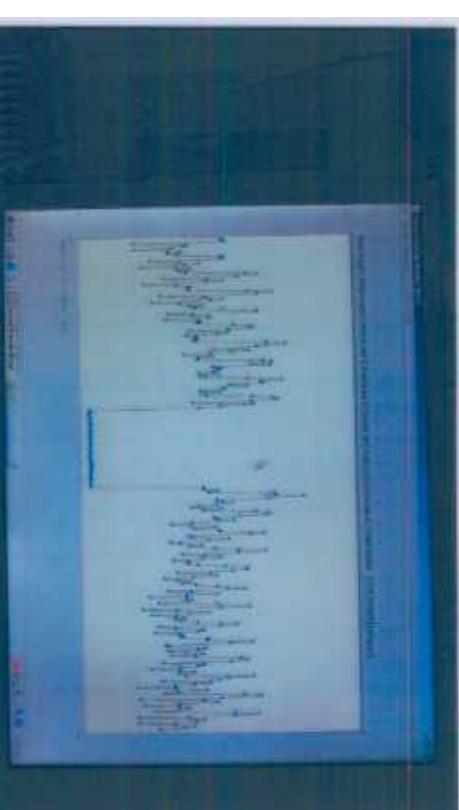
Track and Hold board with self trigger for PMT pulse detection  
(only one bit is used in photon counting mode)



# Experiment Setup



First data (Peak Height distribution)



# Online Results

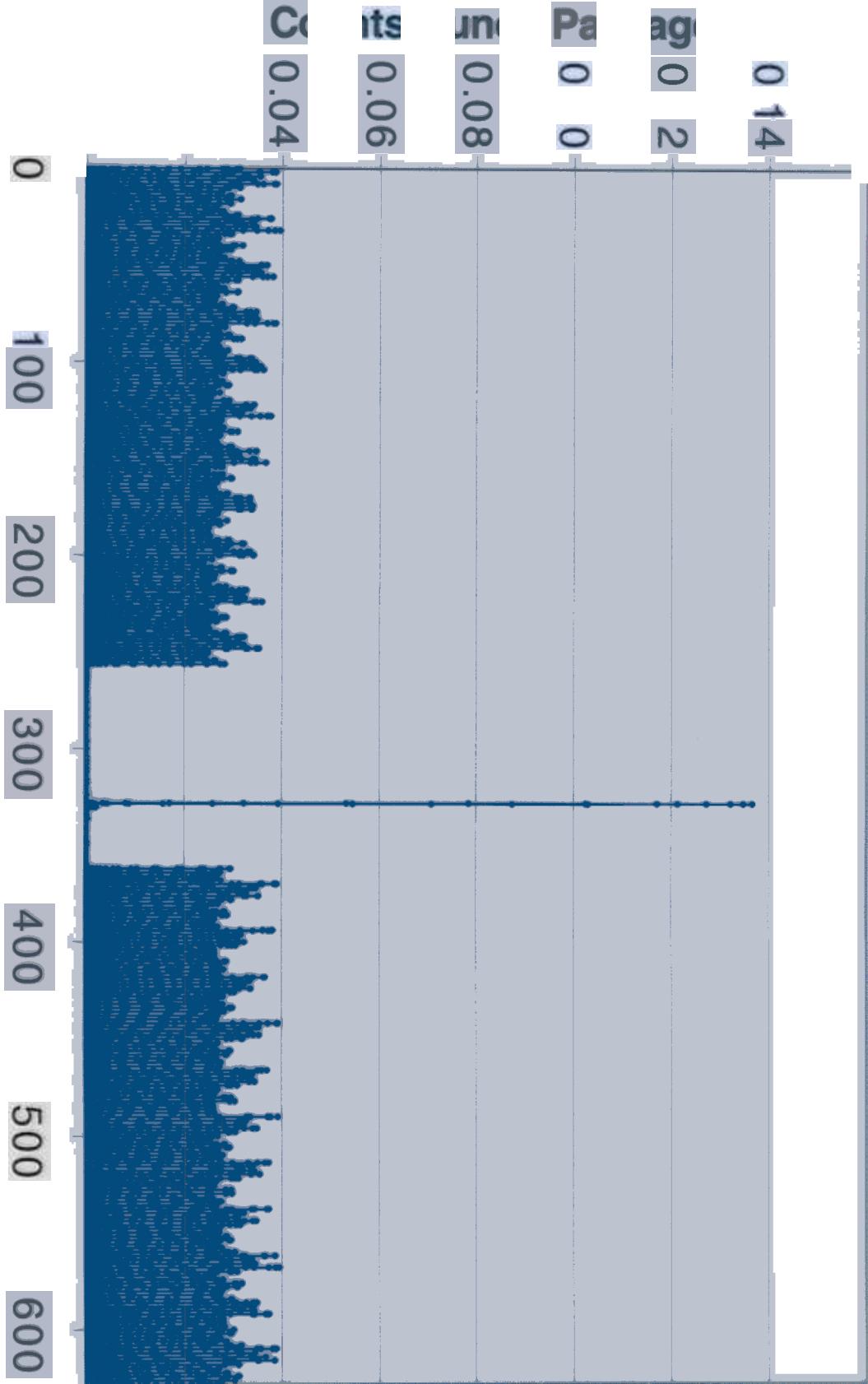
Cam Bunch in ALS Gap 10.15.02



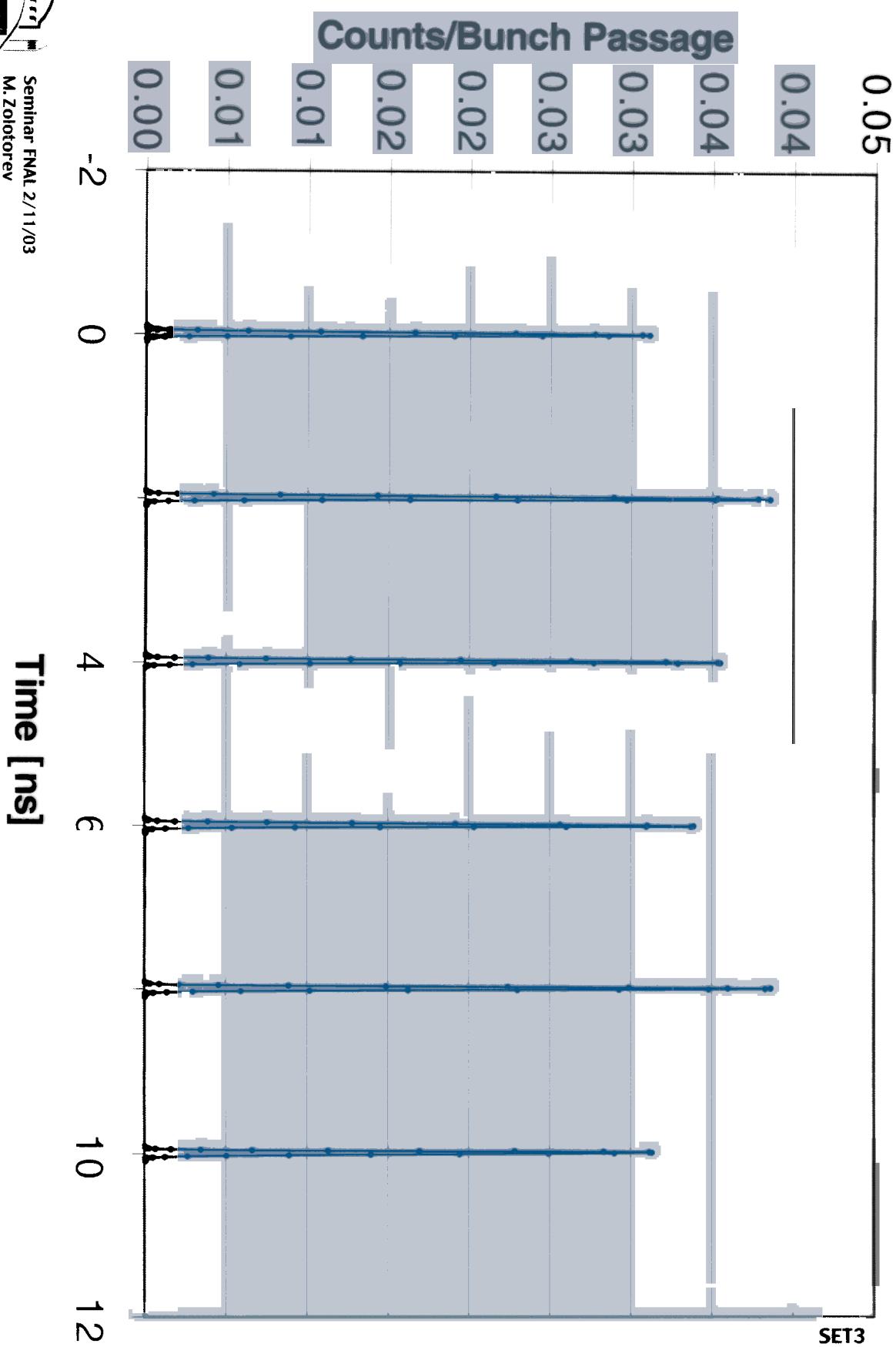
Cam Bunch  
followed by a  
gap and then  
the standard  
bunches.

## ALS Bunch Profile in Time

**SET3**



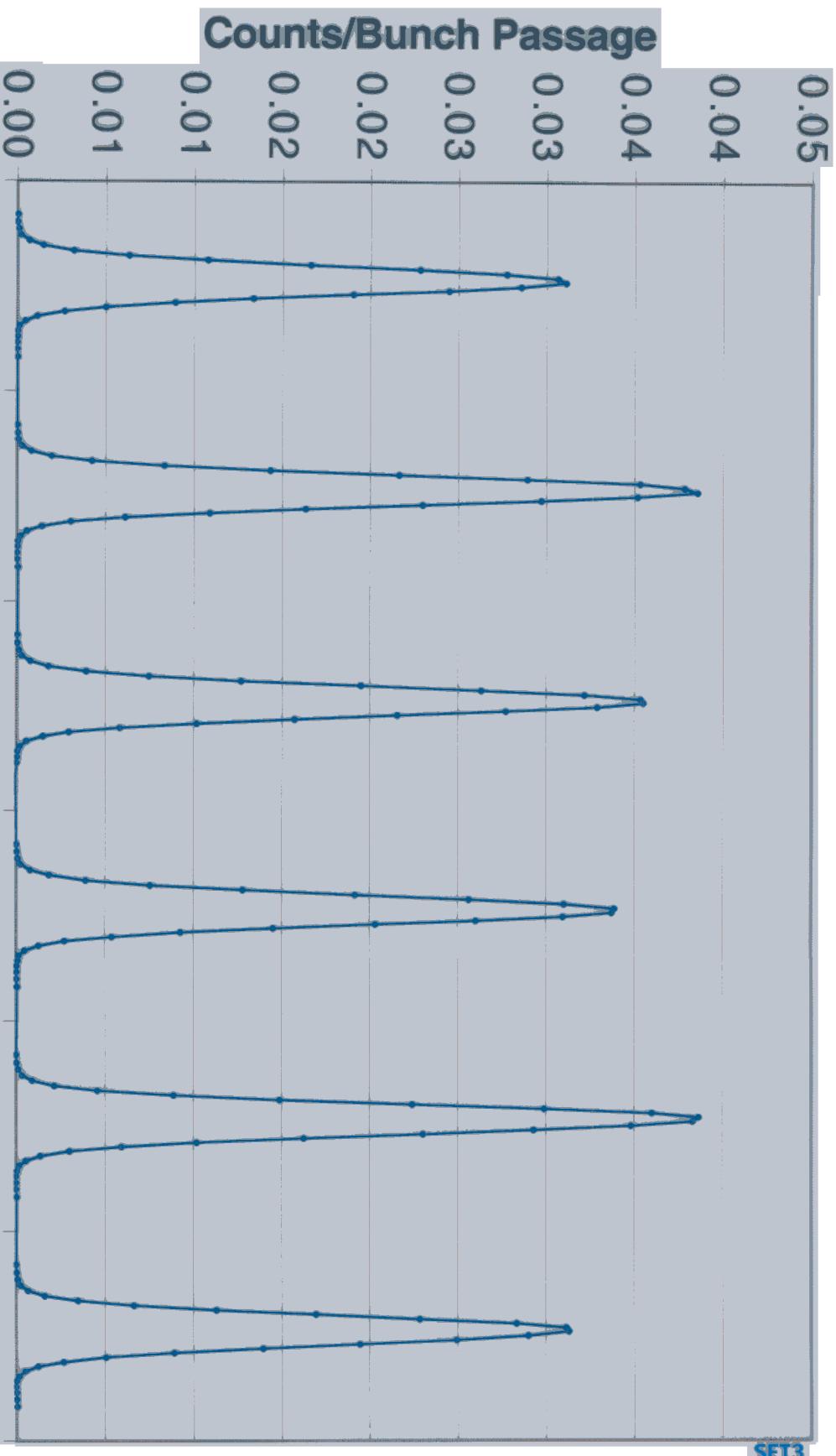
FNAL 2/11/03



Zoom in...

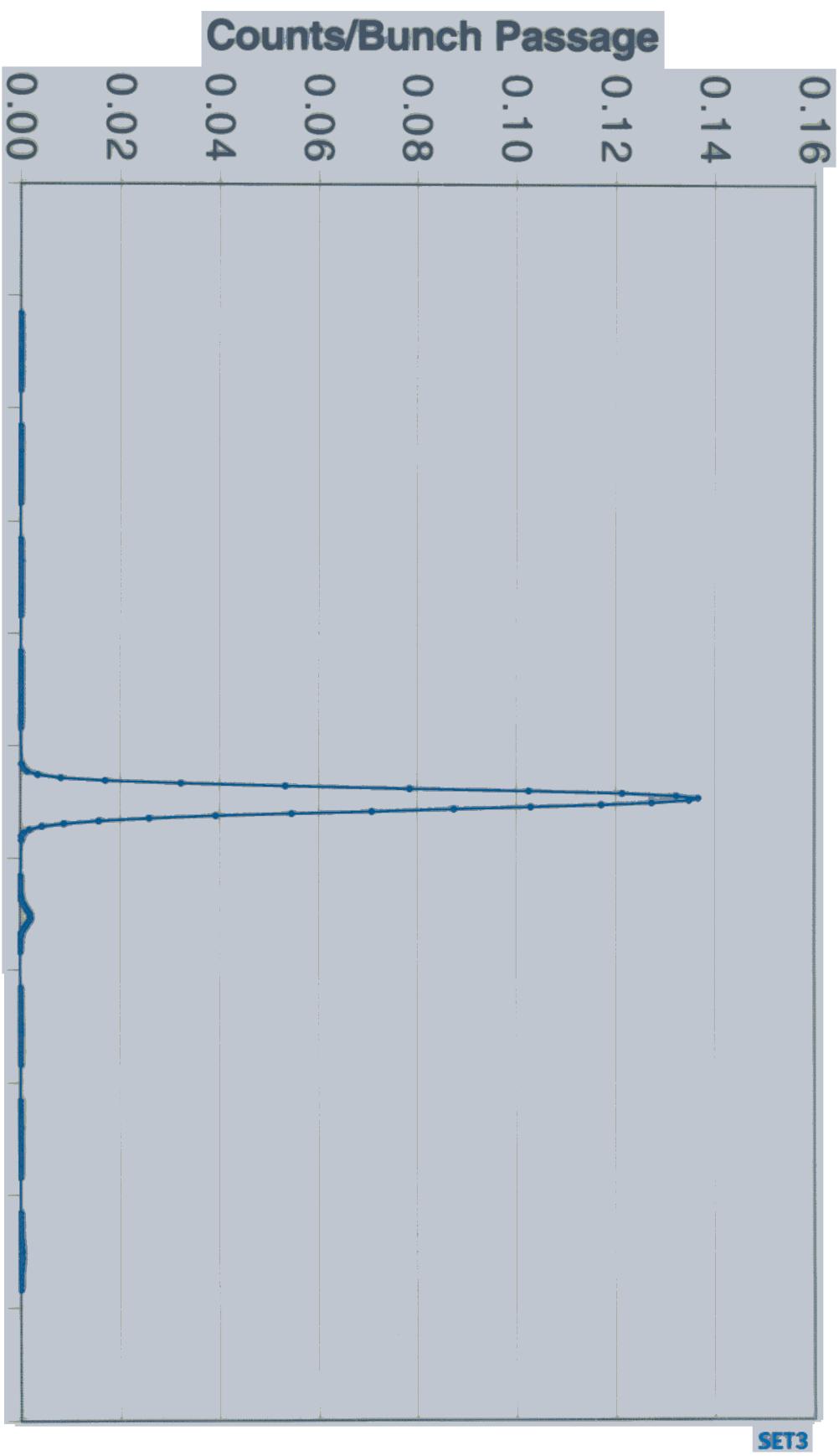


Bunch (270 ps)



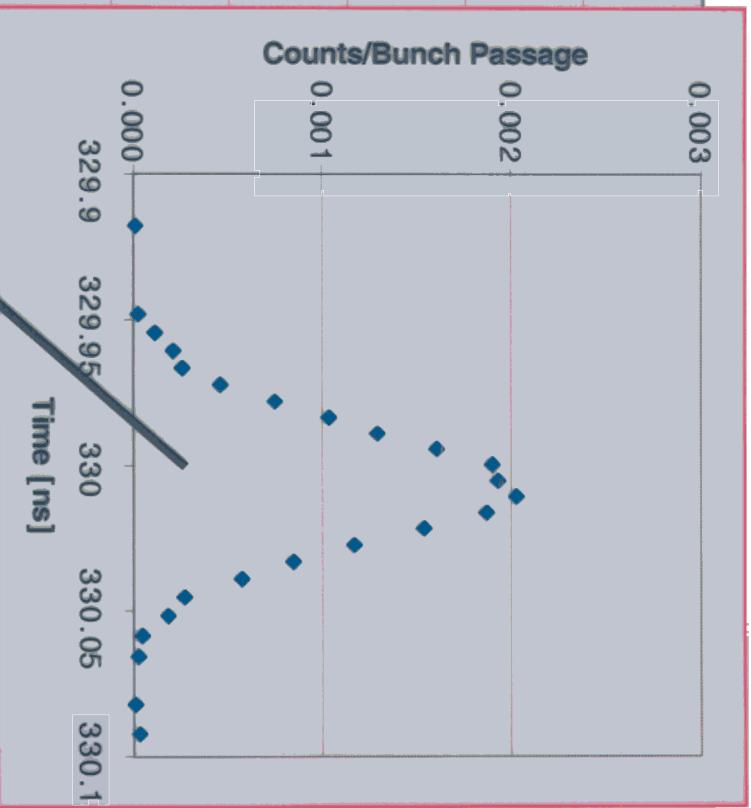
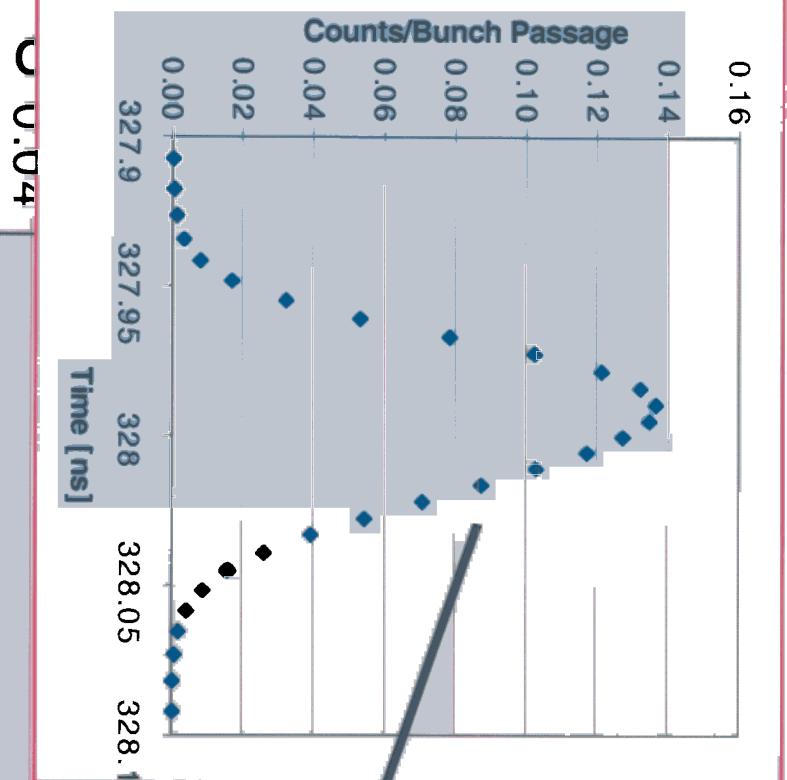
Compress Scale...

## Camshaft Bunch

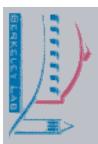
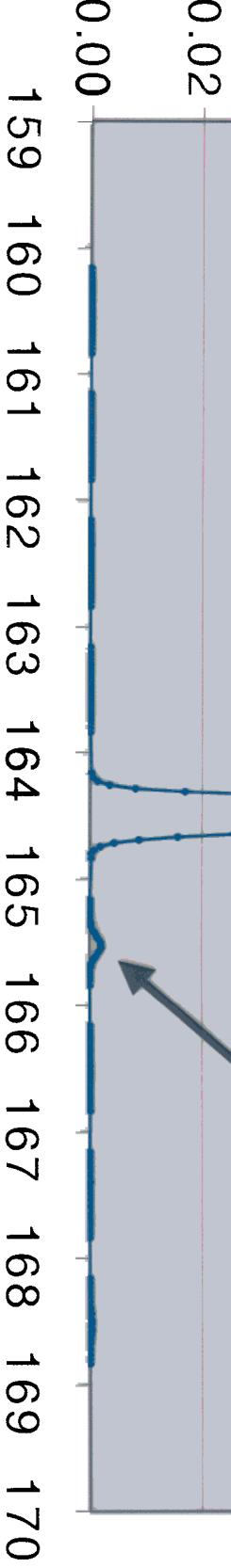


Seminar FNAL 2/11/03  
M. Zolotorev

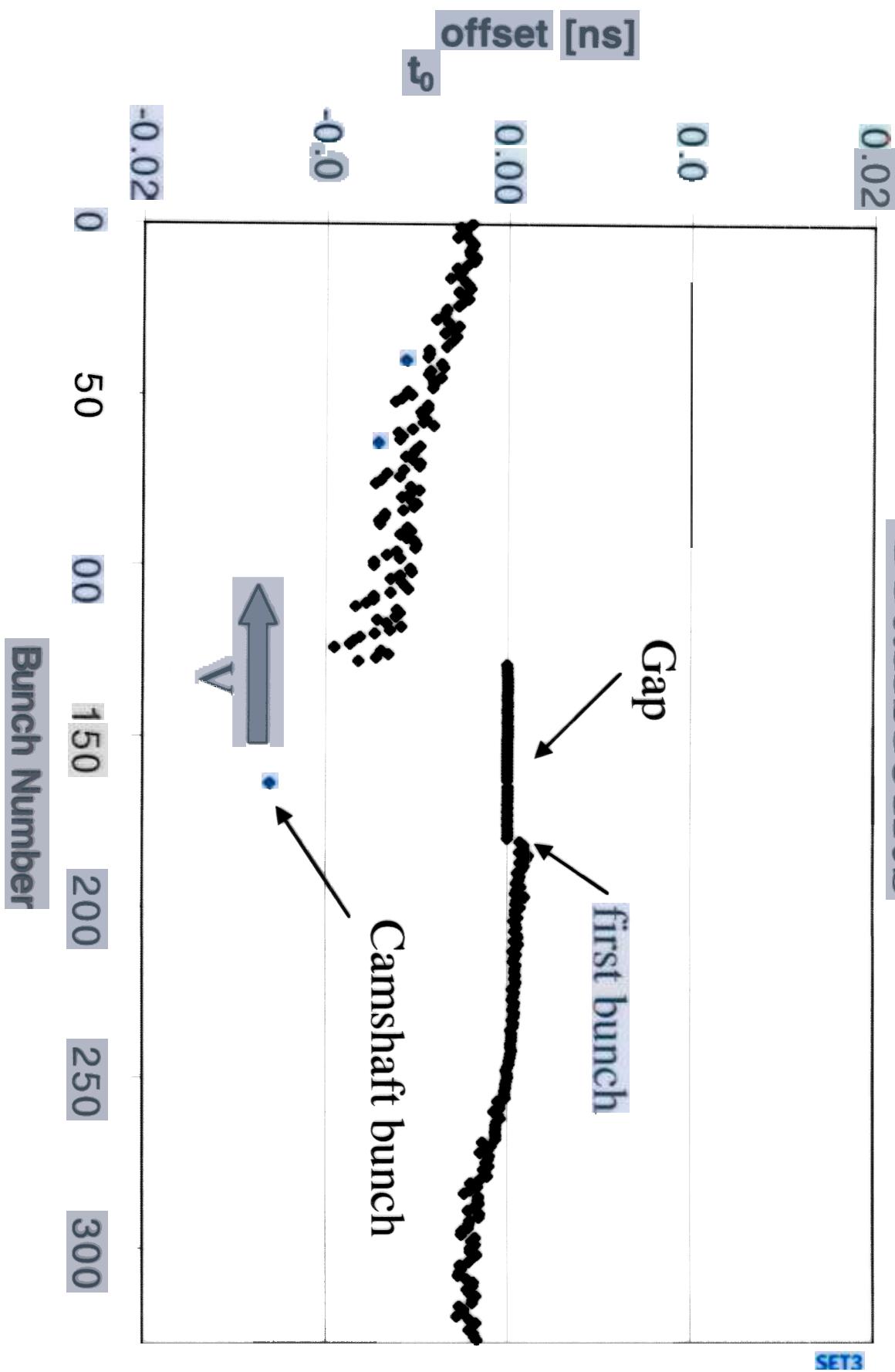
## Details

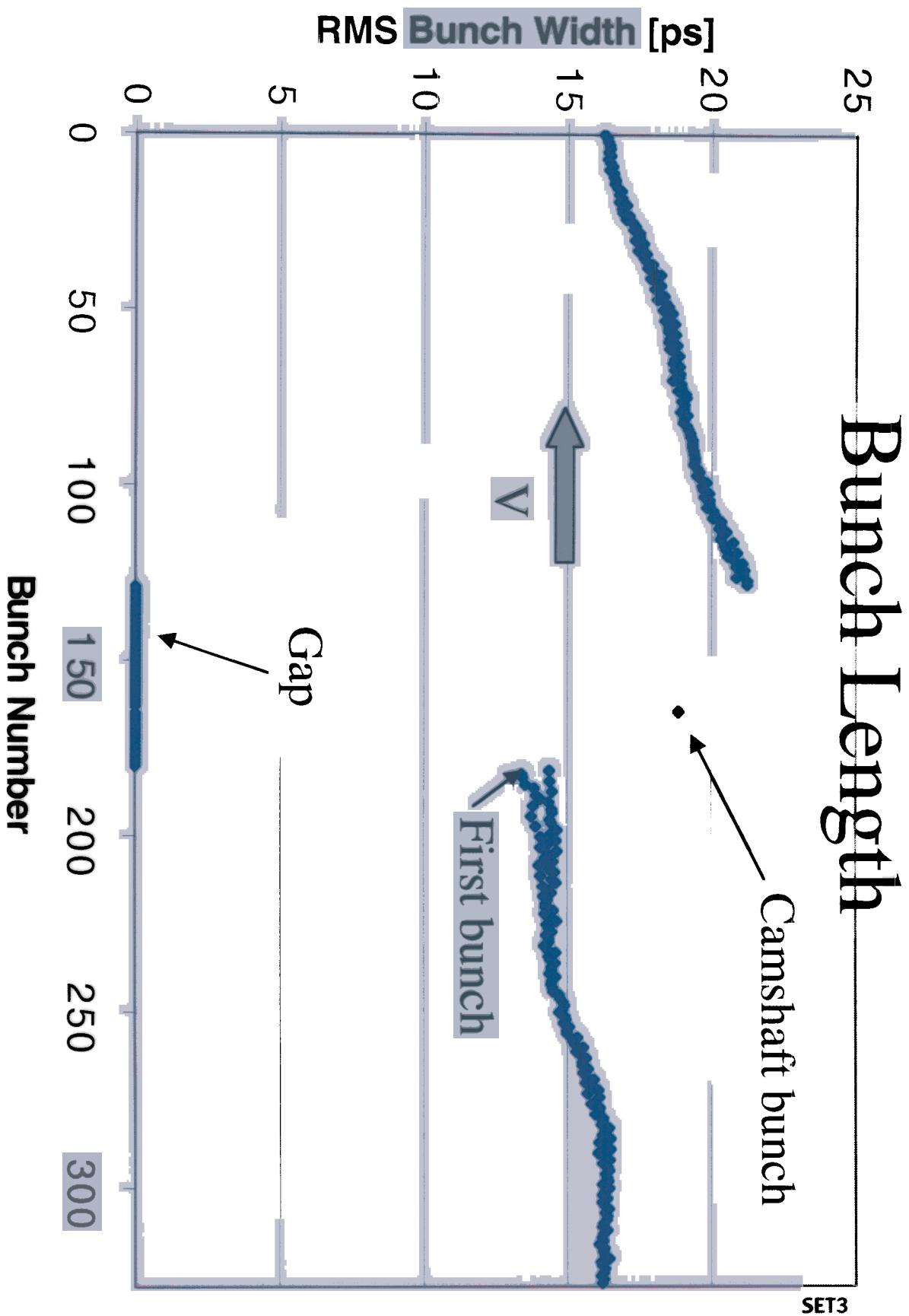


Bunch (270 ps)



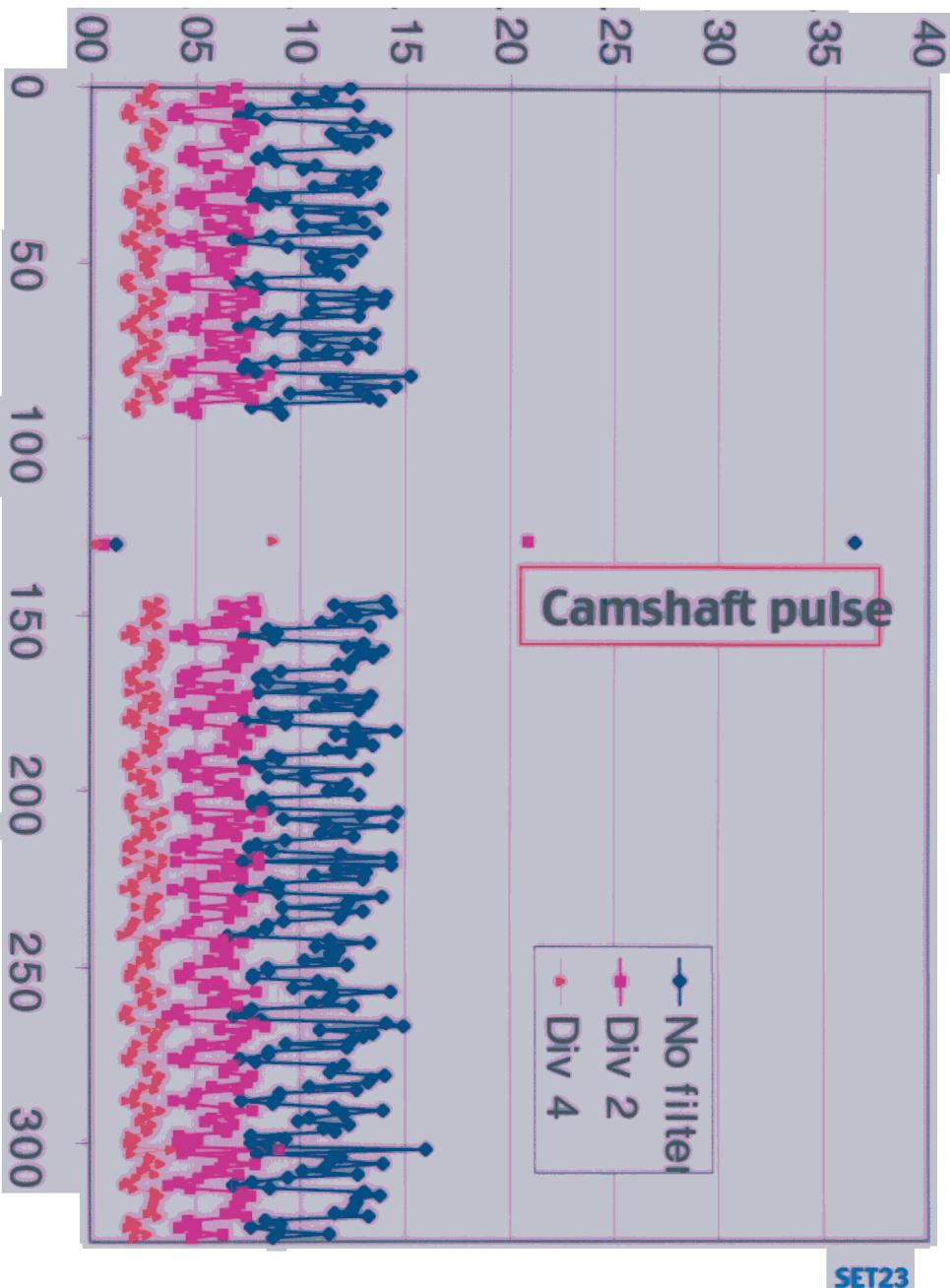
# Synchronous Phase Transients



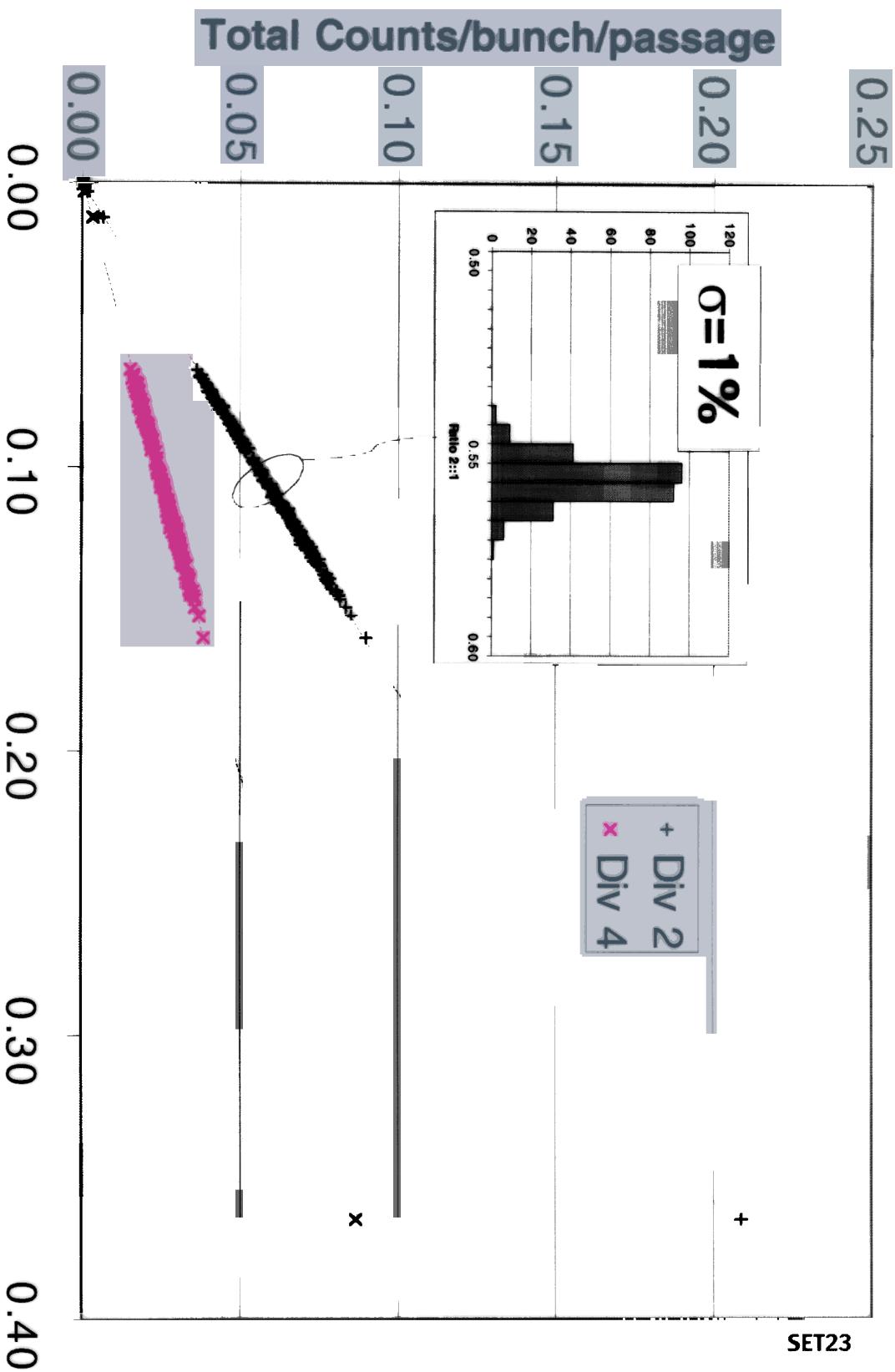


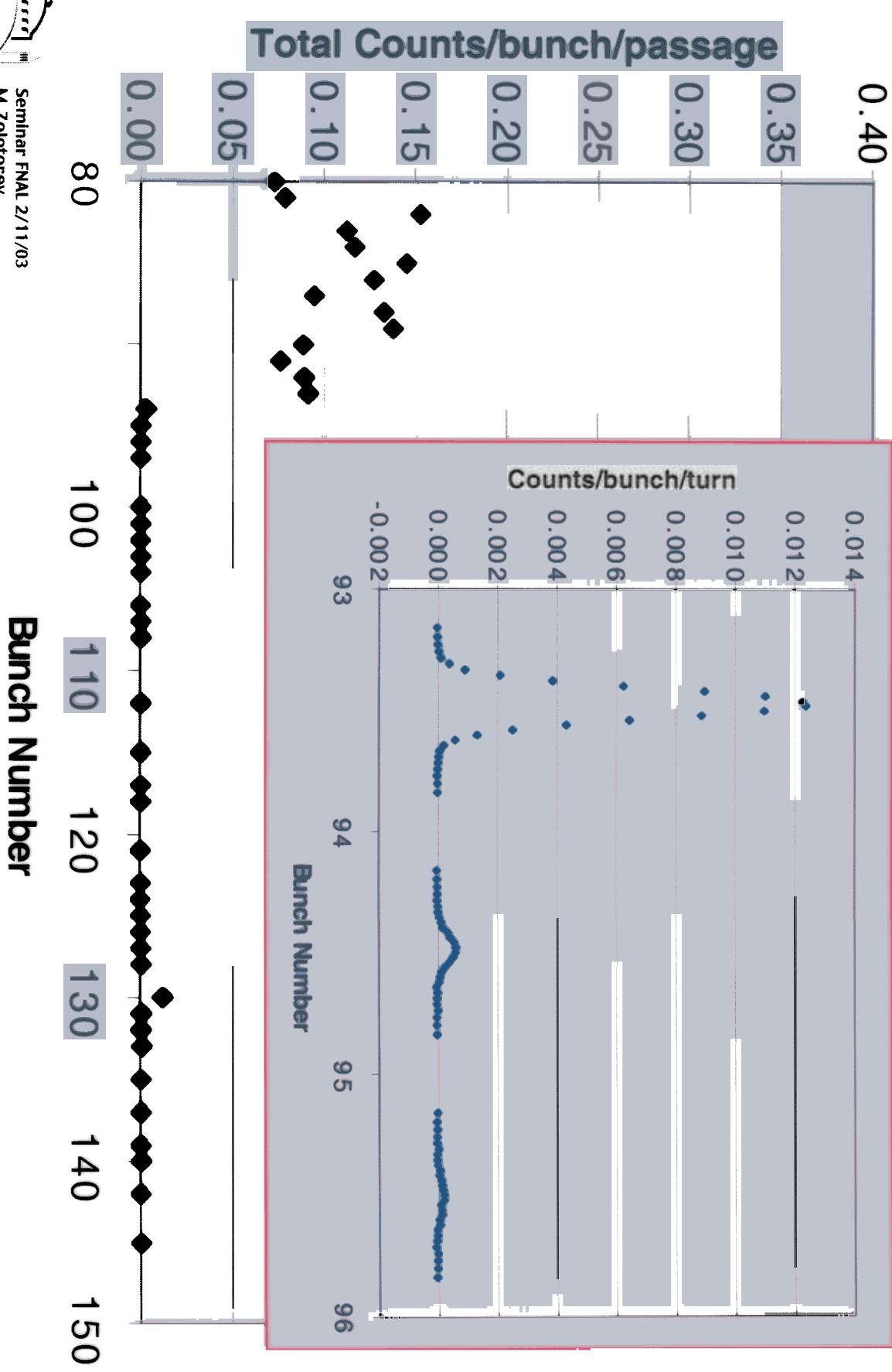
## Linearity...

3 runs – same fill conditions, but put filters in front of PM



**Response is quite linear**





**Zoom - II.**

1.E-01

1.E-02

1.E-03

1.E-04

1.E-05

Counts/bunch/turn

129      130      131      132

Bunch Number

0.05

0.00

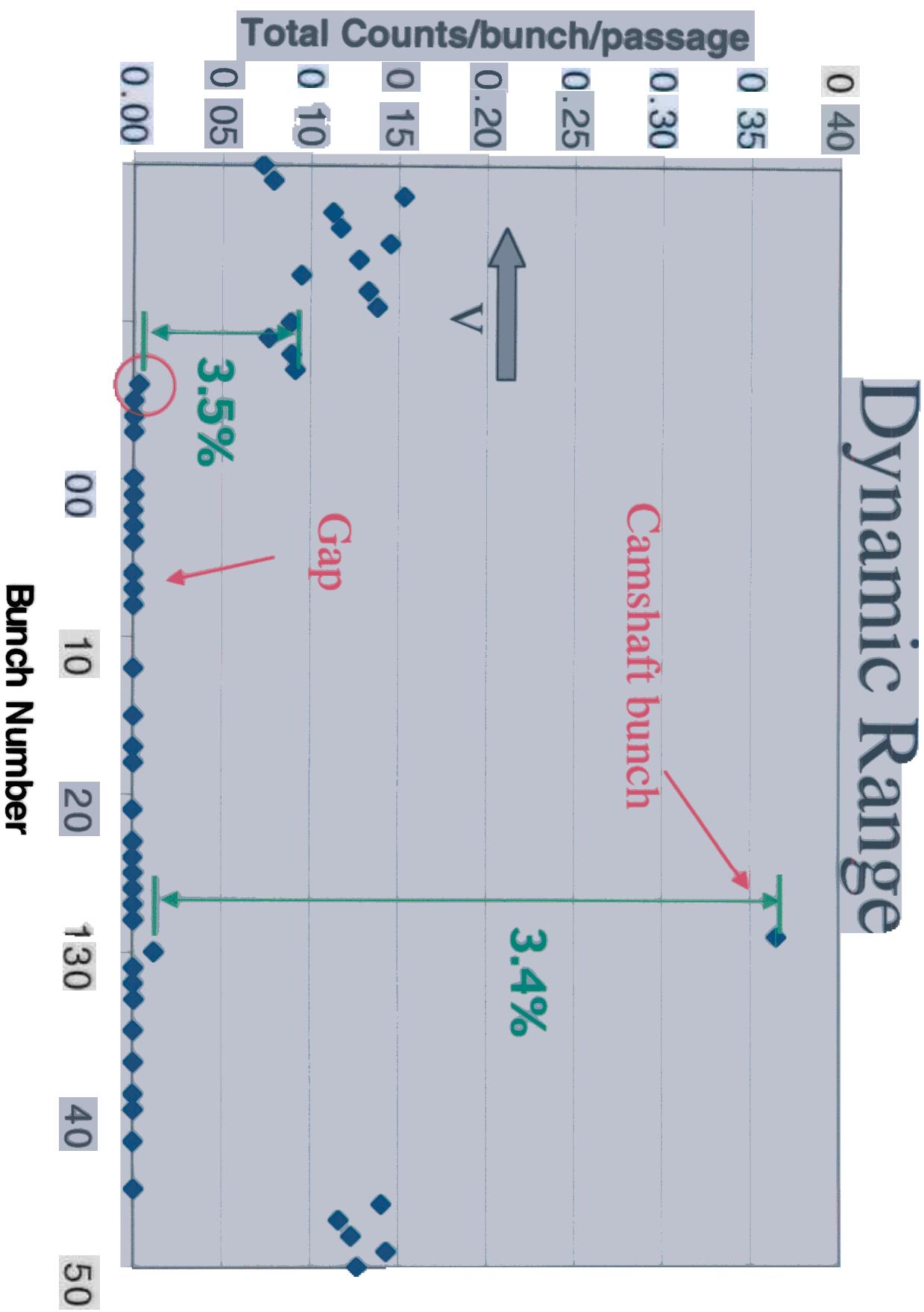
Bunch Number

80      100      110      120      130      140      150

**Camshaft/Background  $\sim 10^3$**



# Interesting Detail Demonstrates Dynamic Range



# Laser for Tevatron, RHIC and LHC

## Modelocked IR-VIS-UV Multi-Watt picosecond Lasers



### IR - multi-Watt infrared picosecond Nd:vanadate lasers

IC-LASER ps Nd:vanadate models:

IC-5000

ps Nd:VAN

2 W

IC-8000

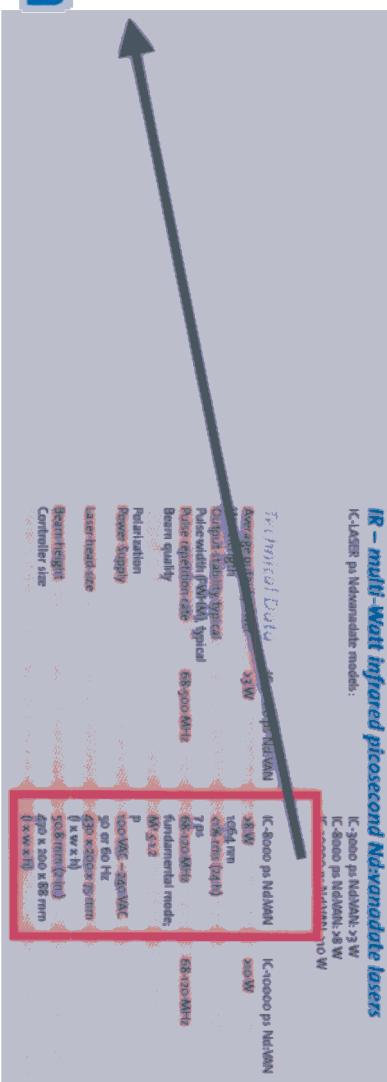
ps Nd:VAN

5 W

IC-10000

ps Nd:VAN

10 W



### VIS - multi-Watt 532-nm picosecond Nd:vanadate lasers

IC-LASER ps frequency-doubled models:  
IC-532-5000 ps Nd:VAN: > 2 W

IC-532-3000 ps Nd:VAN: > 2 W

Higher powers on request

IC-532-3000 ps Nd:VAN: > 2 W

IC-532-5000 ps Nd:VAN: > 2 W

IC-532-10000 ps Nd:VAN: > 2 W

IC-532-20000 ps Nd:VAN: > 2 W

IC-532-40000 ps Nd:VAN: > 2 W

IC-532-60000 ps Nd:VAN: > 2 W

IC-532-80000 ps Nd:VAN: > 2 W

IC-532-100000 ps Nd:VAN: > 2 W

IC-532-120000 ps Nd:VAN: > 2 W

IC-532-140000 ps Nd:VAN: > 2 W

IC-532-160000 ps Nd:VAN: > 2 W

IC-532-180000 ps Nd:VAN: > 2 W

IC-532-200000 ps Nd:VAN: > 2 W

IC-532-220000 ps Nd:VAN: > 2 W

IC-532-240000 ps Nd:VAN: > 2 W

IC-532-260000 ps Nd:VAN: > 2 W

IC-532-280000 ps Nd:VAN: > 2 W

IC-532-300000 ps Nd:VAN: > 2 W

IC-532-320000 ps Nd:VAN: > 2 W

IC-532-340000 ps Nd:VAN: > 2 W

IC-532-360000 ps Nd:VAN: > 2 W

IC-532-380000 ps Nd:VAN: > 2 W

IC-532-400000 ps Nd:VAN: > 2 W

IC-532-420000 ps Nd:VAN: > 2 W

IC-532-440000 ps Nd:VAN: > 2 W

IC-532-460000 ps Nd:VAN: > 2 W

IC-532-480000 ps Nd:VAN: > 2 W

IC-532-500000 ps Nd:VAN: > 2 W

IC-532-520000 ps Nd:VAN: > 2 W

IC-532-540000 ps Nd:VAN: > 2 W

IC-532-560000 ps Nd:VAN: > 2 W

IC-532-580000 ps Nd:VAN: > 2 W

IC-532-600000 ps Nd:VAN: > 2 W

IC-532-620000 ps Nd:VAN: > 2 W

IC-532-640000 ps Nd:VAN: > 2 W

IC-532-660000 ps Nd:VAN: > 2 W

IC-532-680000 ps Nd:VAN: > 2 W

IC-532-700000 ps Nd:VAN: > 2 W

IC-532-720000 ps Nd:VAN: > 2 W

IC-532-740000 ps Nd:VAN: > 2 W

IC-532-760000 ps Nd:VAN: > 2 W

IC-532-780000 ps Nd:VAN: > 2 W

IC-532-800000 ps Nd:VAN: > 2 W

IC-532-820000 ps Nd:VAN: > 2 W

IC-532-840000 ps Nd:VAN: > 2 W

IC-532-860000 ps Nd:VAN: > 2 W

IC-532-880000 ps Nd:VAN: > 2 W

IC-532-900000 ps Nd:VAN: > 2 W

IC-532-920000 ps Nd:VAN: > 2 W

IC-532-940000 ps Nd:VAN: > 2 W

IC-532-960000 ps Nd:VAN: > 2 W

IC-532-980000 ps Nd:VAN: > 2 W

IC-532-1000000 ps Nd:VAN: > 2 W

IC-532-1020000 ps Nd:VAN: > 2 W

IC-532-1040000 ps Nd:VAN: > 2 W

IC-532-1060000 ps Nd:VAN: > 2 W

IC-532-1080000 ps Nd:VAN: > 2 W

IC-532-1100000 ps Nd:VAN: > 2 W

IC-532-1120000 ps Nd:VAN: > 2 W

IC-532-1140000 ps Nd:VAN: > 2 W

IC-532-1160000 ps Nd:VAN: > 2 W

IC-532-1180000 ps Nd:VAN: > 2 W

IC-532-1200000 ps Nd:VAN: > 2 W

IC-532-1220000 ps Nd:VAN: > 2 W

IC-532-1240000 ps Nd:VAN: > 2 W

IC-532-1260000 ps Nd:VAN: > 2 W

IC-532-1280000 ps Nd:VAN: > 2 W

IC-532-1300000 ps Nd:VAN: > 2 W

IC-532-1320000 ps Nd:VAN: > 2 W

IC-532-1340000 ps Nd:VAN: > 2 W

IC-532-1360000 ps Nd:VAN: > 2 W

IC-532-1380000 ps Nd:VAN: > 2 W

IC-532-1400000 ps Nd:VAN: > 2 W

IC-532-1420000 ps Nd:VAN: > 2 W

IC-532-1440000 ps Nd:VAN: > 2 W

IC-532-1460000 ps Nd:VAN: > 2 W

IC-532-1480000 ps Nd:VAN: > 2 W

IC-532-1500000 ps Nd:VAN: > 2 W

IC-532-1520000 ps Nd:VAN: > 2 W

IC-532-1540000 ps Nd:VAN: > 2 W

IC-532-1560000 ps Nd:VAN: > 2 W

IC-532-1580000 ps Nd:VAN: > 2 W

IC-532-1600000 ps Nd:VAN: > 2 W

IC-532-1620000 ps Nd:VAN: > 2 W

IC-532-1640000 ps Nd:VAN: > 2 W

IC-532-1660000 ps Nd:VAN: > 2 W

IC-532-1680000 ps Nd:VAN: > 2 W

IC-532-1700000 ps Nd:VAN: > 2 W

IC-532-1720000 ps Nd:VAN: > 2 W

IC-532-1740000 ps Nd:VAN: > 2 W

IC-532-1760000 ps Nd:VAN: > 2 W

IC-532-1780000 ps Nd:VAN: > 2 W

IC-532-1800000 ps Nd:VAN: > 2 W

crystal in cavity will  
improves efficiency

Technical Data	IC-532-5000 ps Nd:VAN	IC-532-3000 ps Nd:VAN	IC-532-500 ps Nd:VAN
Average output power	5 W	3 W	0.5 W
Wavelength	532 nm	532 nm	532 nm
Output stability typical	< 5%	< 5%	< 5%
Pulsewidth (FWHM), typical	6 fs	6 fs	6 fs
Pulse repetition rate	10 Hz	10 Hz	10 Hz
Polarization	< 5%	< 5%	< 5%
Power supply	100 VAC - 400 VAC	100 VAC - 400 VAC	100 VAC - 400 VAC
Laser head size	520 x 300 x 170 mm	520 x 300 x 170 mm	520 x 300 x 170 mm
Beam size	[1 w x t] 50 x 50 mm [HxW]	[1 w x t] 50 x 50 mm [HxW]	[1 w x t] 50 x 50 mm [HxW]
Beam divergence	0.05 mrad	0.05 mrad	0.05 mrad
Beam pointing	0.1 mrad	0.1 mrad	0.1 mrad
Beam steering	0.1 mrad	0.1 mrad	0.1 mrad
Beam holding time	4 hours	4 hours	4 hours
Beam repositioning time	4 hours	4 hours	4 hours

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www.highqlaser.com





$$\lambda = 4 \mu$$

$$\lambda_{\text{up}} = 0.8 \mu$$

For  $10^{10}$  p/cm

Ga As photocathode tube Q.E.  $\approx 50\%$

1000 GeV

150 GeV

$N_{\text{up}}$	800	0.01
$T(1\%)$	10 ms	20 min

## All-in-One Tool

- Do not require visible light
- Can work from 150 - 1000 GeV

### Very wide dynamic range

### • Online bunch length

Intensity - including intensity in gaps  
(making it easy to diagnose unfilled buckets)

### • Phase transients

- Fast: the results shown were accumulated in seconds-minutes

# Preliminary Budgetary Estimate

## One Longitudinal Density System

**\$183k**

SY

\$100k  
\$ 38k  
\$ 55k

Max,

**\$127k**

attached is the slide Bill and I prepared for the cost estimate of the LDM for FNAL. Given the assumptions are very rough and we did it very quickly, I suspect this is -0, +30% accurate!! The slide shows no contingency, and I think 25% would be appropriate. Once we talk more with FNAL and have a better understanding of what we need to do, this can be refined and the error bars reduced.

Let me know if you have questions.

Alex

\$ 75k  
\$ 12k  
\$ 10k  
\$ 30k

•Total (include ovhd)

**\$310k**

onics

~6 mo.

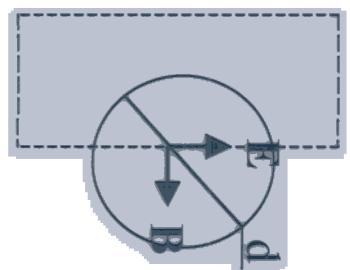
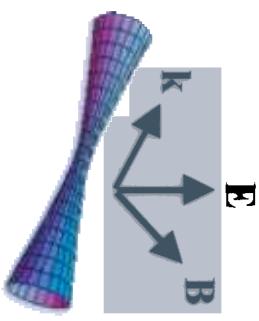
•Materials

-Optical comp.  
-PMT, PDs

# Light Fluctuation and Longitudinal Density Monitor

Catravas, P.  
Sajaev, V.  
Stupakov, G.  
Zolotorev, M.

# Diffraction and Coherence



$$\mathbf{E} \cdot d \approx B k d^2 \theta_{\text{dif}} \quad \oint \vec{E} \cdot d\vec{l} = \frac{\sigma}{c \partial t} \int \vec{B} \cdot d\vec{A}$$

Transverse coherence

$$\theta_{\text{dif}} \approx \frac{1}{kd}$$

Longitudinal coherence

$$d_{\perp} = \frac{1}{k \theta}$$

$$l_{\parallel} = \frac{c}{\Delta\omega}$$

Volume of coherence

$$V_c = d_{\perp}^2 l_{\parallel}$$

Degeneracy parameter == number of photons in volume of coherence



# Degeneracy parameter

When degeneracy parameter is much greater than 1  
The radiated field can be treated classically

rmal source

$$\frac{1}{\text{Exp}[\hbar v/kT] - 1} \approx 1$$

nchrotron radiation

$$\approx \alpha N \lambda / c \tau$$

$$\approx 10^4$$

3 Laser

## Superposition and radiation of beam

$$\mathbf{E}_s(\mathbf{t}, \mathbf{r}) = \sum \mathbf{e}_s(\mathbf{t} - \mathbf{\tau}_i, \mathbf{r} - \mathbf{r}_i)$$

$$\mathbf{E}_s(\omega, \vec{k}) = \mathbf{e}_s(\omega, \vec{k}) \sum e^{i \vec{k} \vec{r}_i - i \omega \tau_i}$$

If  $k a \theta \ll 1$        $a \ll d_c$

$$\mathbf{E}_s(\omega, \theta) = \mathbf{e}_s(\omega, \theta) \sum e^{-i \omega \tau_i} = \mathbf{e}_s(\omega, \theta)(\omega)$$

Incoherent radiation  $\omega \tau_b \gg 1$

amplitude  $\mathbf{E}_s(\omega, \theta) \sim N^{1/2}$

intensity  $\sim |\mathbf{E}_s(\omega, \theta)|^2 \sim N$

Coherent radiation  $\omega \tau_b \ll 1$

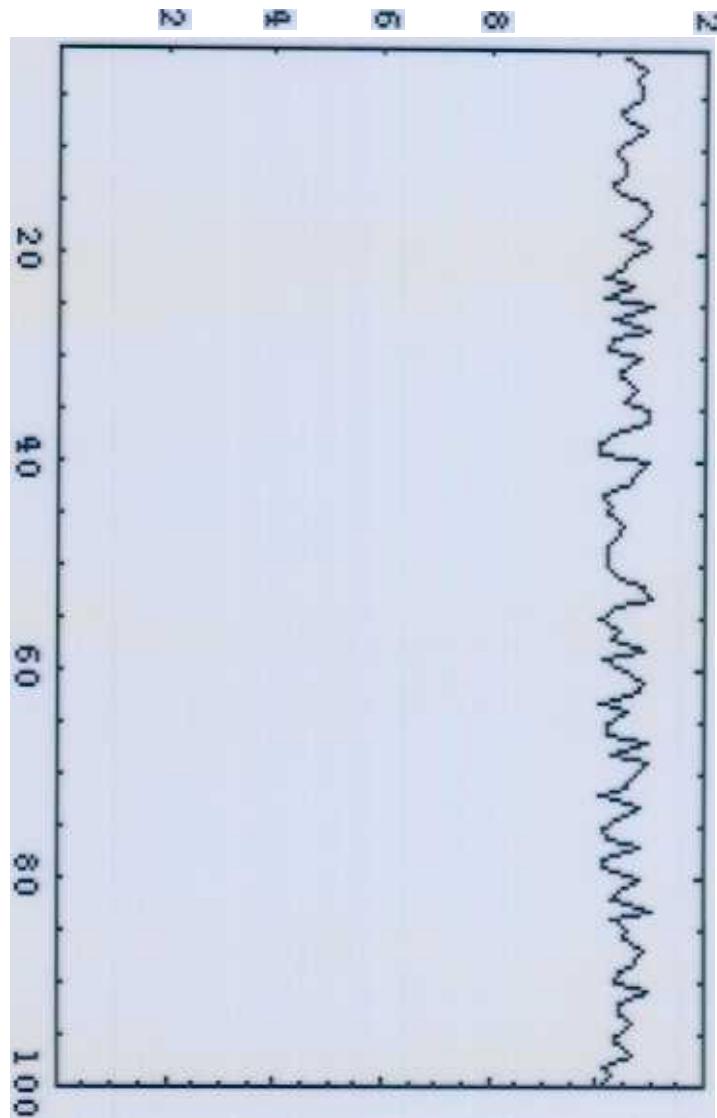
amplitude  $\mathbf{E}_s(\omega, \theta) \sim N$

intensity  $\sim |\mathbf{E}_s(\omega, \theta)|^2 \sim N^2$



DC current can not radiate!

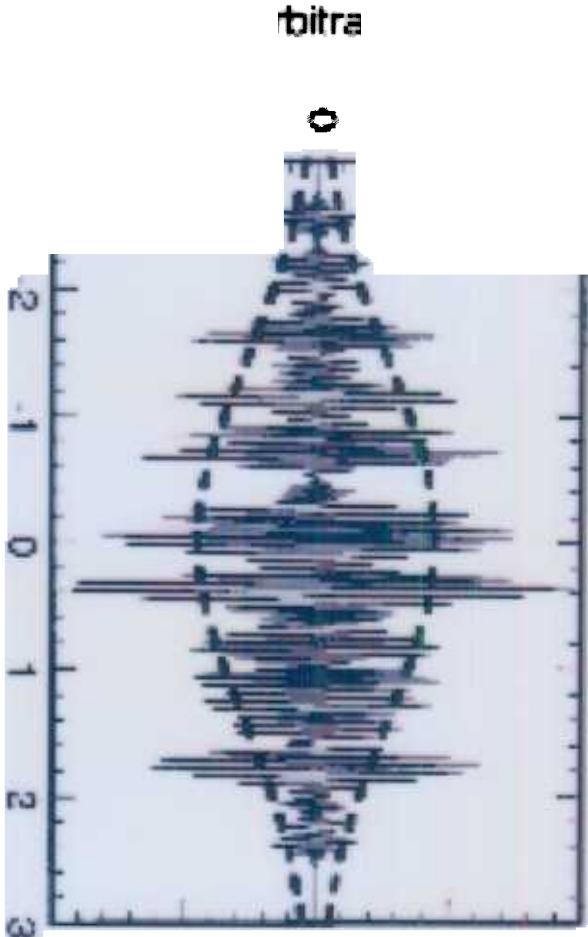
Incoherent Radiation by definition can come only from fluctuation (Noise) in beam density



Can information about longitudinal charge distribution be extracted from the incoherent radiation



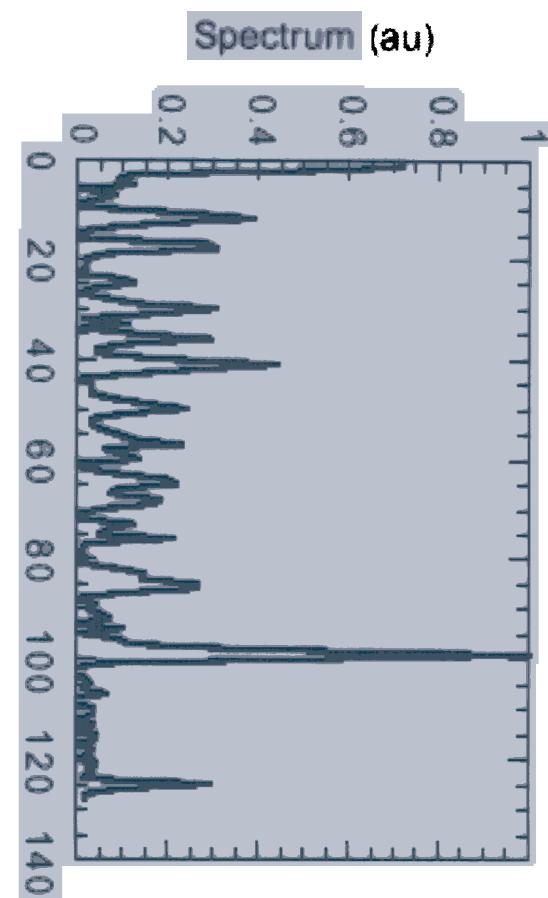
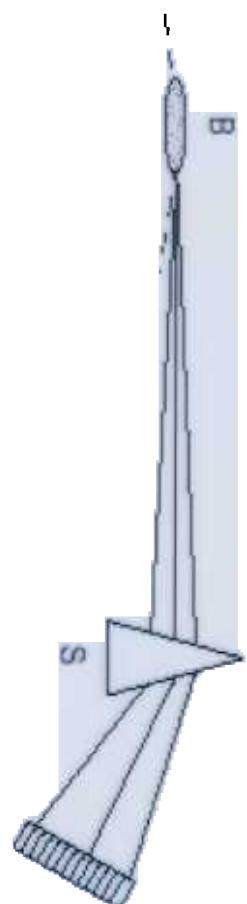
## Time Domain



Time domain picture of incoherent radiation from Gaussian longitudinal charge distribution after filter with  $\omega_0/\Delta\omega = 10$  and  $\tau \approx 10/\Delta\omega$

Pulse to pulse fluctuation in intensity under these conditions will be roughly  $1/\sqrt{M}$ , where  $M$  is the number of groups. In this case  $M \approx 10$  and the fluctuation will be 30%. This does not depend on the number of electrons if the degeneracy parameter is large. For a known filter bandwidth and measured fluctuation the pulse length can be recovered.

## Frequency Domain

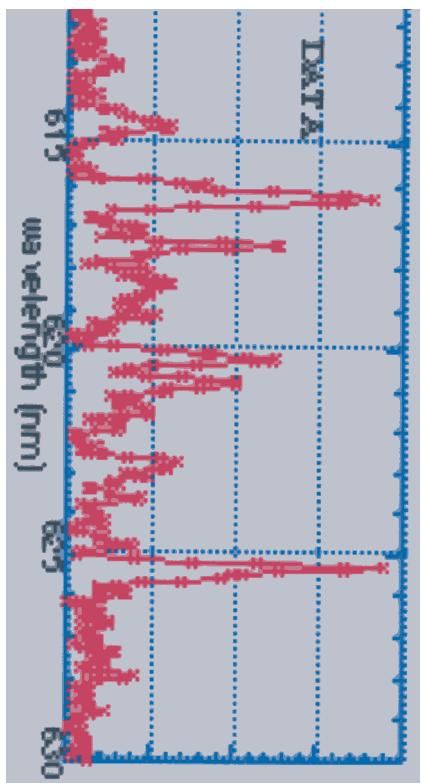


CCD Channel Number

Spectral fluctuations: narrow spikes with width  $1/\tau_b$ .

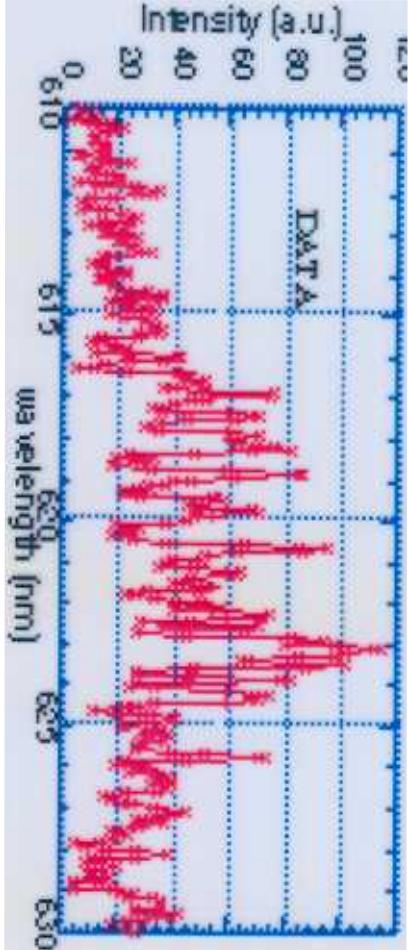


# ability distribution for spikes



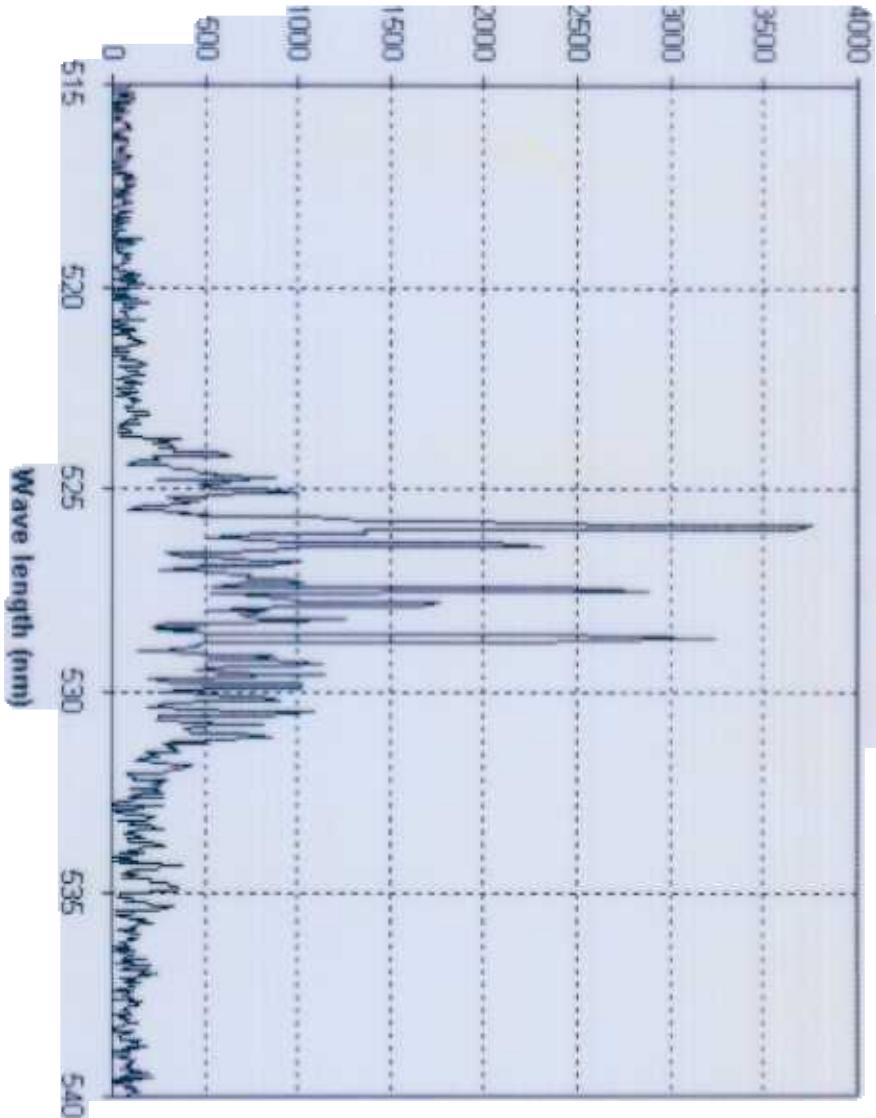
For beam size smaller than transverse coherence size and/or resolution of spectrometer  $\Delta\omega < 1/\tau_b$ , follows the Poisson distribution

For beam size larger than transverse coherence size and/or resolution of spectrometer  $\Delta\omega > 1/\tau_b$ , follows the Gamma distribution



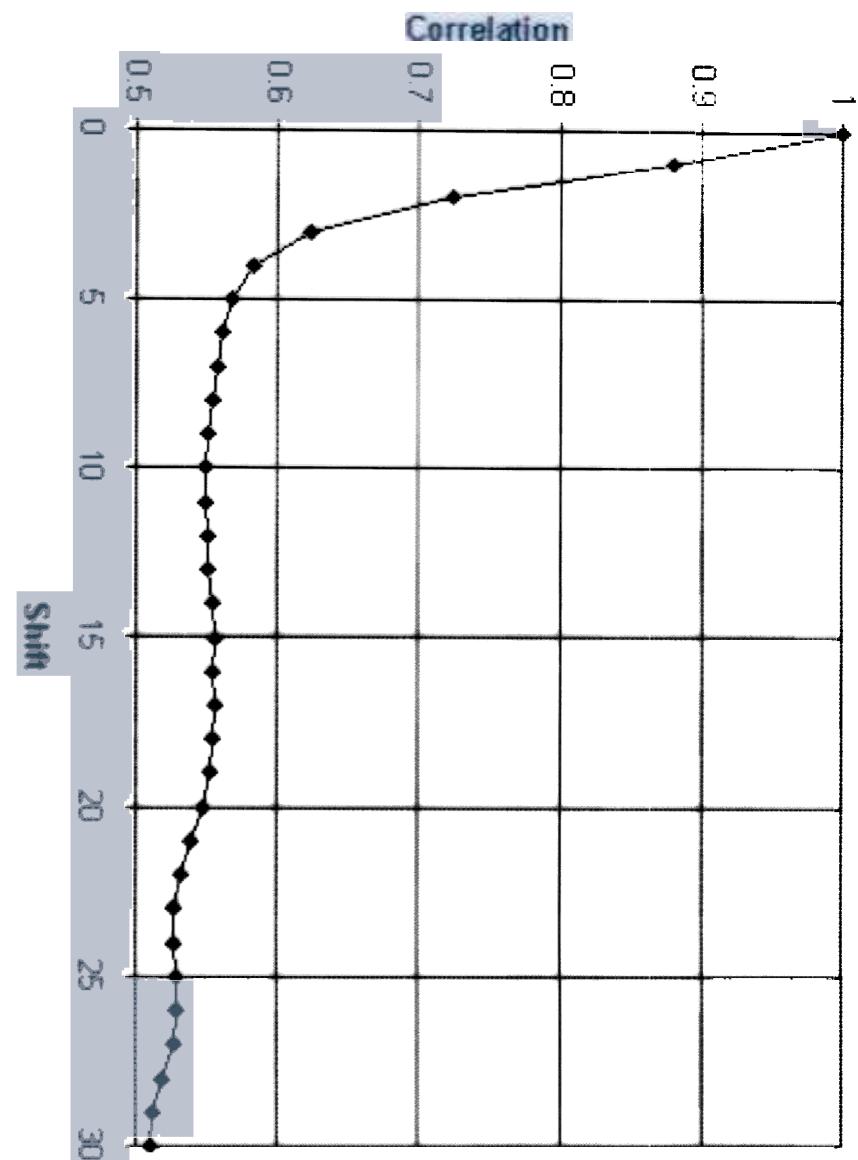
Experimental data taken at Brookhaven National Lab

## Single shot spectrum



Experimental data taken at Argon National Lab

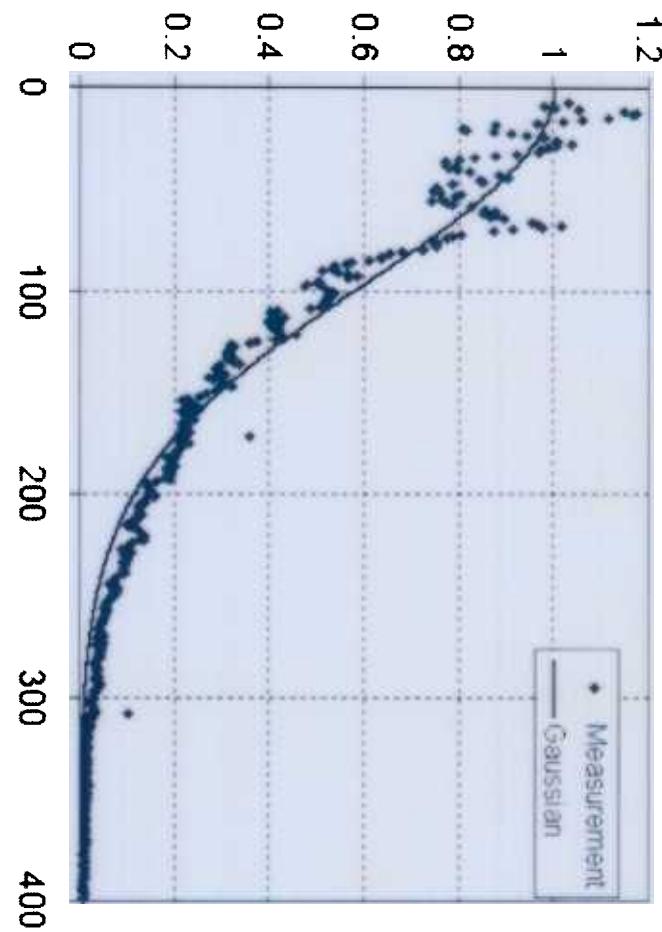
## Spectrum autocorrelation



For no pedestal autocorrelation should go to .5  
Spectral width of the spike can be seen to be ~ 2 pixels of ccd  
for this experiment this corresponds to 1/2 ps.

Fourier transform of spectral auto-correlation function gives convolution function of particle charge density

### Convolution of particle density



Knowledge of the convolution function does not allow a unique restoration of  $I(t)$ .



One can try to recover I(t) using the suggestion  
of Lai and Sievers Micro Bunches Workshop AIP Conf Proc 367 1995

$$S(\omega) = \rho(\omega) e^{i\psi(\omega)} .$$

$$\psi_m(\omega) + \psi_{Blaschke}(\omega) = - \frac{2\omega}{\pi} \int_0^\infty dx \frac{\ln \rho(x)}{x^2 - \omega^2} + \sum \arg \left( \frac{\omega - \omega_j}{\omega - \omega_j^*} \right)$$

$$\psi_m(\omega) = - \frac{2\omega}{\pi} P \int_0^\infty dx \frac{\ln [\rho(x)/\rho(\omega)]}{x^2 - \omega^2}$$





Bunch shape recovered using this technique, averaged over 100 pulses. (Sajaev, V proceedings of EPAC 2000)

